

Practitioner's Docket No.:

L&L-I0242

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Laurence A. GreenbergFebruary 14, 2006
DateIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/694,593 Confirmation No.: 3503
Applicant : Olaf Storbeck, et al.
Filed : October 27, 2003
Title : Method for Minimizing the Vapor
Deposition of Tungsten Oxide During the
Selective Side Wall Oxidation of
Tungsten-Silicon Gates
Art Unit : 2823
Examiner : Fernando L. Toledo
Customer No. : 24131

PRELIMINARY AMENDMENT

Mail Stop Non Fee Amendment
Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S i r :

Responsive to the Advisory Action dated January 24, 2006 and further responsive to the Office action dated October 14, 2005, kindly amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.